

eGaN[®] FET Safe Operating Area

Rugged eGaN FETs demonstrate superior safe operating area

A basic limitation of a power transistor is temperature. Calculations of device temperature during operation assume that power dissipation is spread evenly over the entire active area of the device, which is not always true. Because of negative temperature coefficients in certain parameters of some technologies, current may crowd into a small area, pushing up the localized temperature until failure.

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Safe Operating Area (SOA) curves describe the range of voltage and current and the length of time under which a device may operate without failure. The SOA is an indicator of the device's ability to transfer heat away from a resistive junction and, thus, is directly dependent on a device's Thermal Resistance ($R_{\theta JC}$). The more efficient a device is at getting rid of generated heat, the lower $R_{\theta JC}$ and the better the SOA performance.

eGaN FETs from Efficient Power Conversion (EPC) exhibit a positive temperature coefficient across their entire operating range and can therefore be expected to operate with only voltage, current, and temperature limitations. This article will describe the theoretical SOA of power eGaN FETs which demonstrate very good SOA characteristics while maintaining superior $R_{DS(ON)}$. The article will then compare theoretical calculations with measured results.

History:

The Safe Operating Area of a power device describes its ability to handle voltage and current simultaneously while the gate voltage is at or just above threshold. Limits on SOA are typically due to a negative temperature coefficient which causes current crowding. An example of this crowding is sometimes seen in the base emitter junction in bipolar junction transistors (known as second breakdown).

Early power MOSFETs had significantly lower current where the transfer characteristics' temperature coefficient transitioned from negative to positive (zero-tempco point). Cell densities in today's devices have increased which improve the device's on-resistance ($R_{DS(ON)}$). Most datasheets for early MOS-

FETs showed the theoretical SOA, which was okay since the small area of negative temperature coefficient did not present an additional limitation to voltage, current and temperature. The modern MOSFET, however, has a significant area of negative temperature coefficient in its transfer characteristics curve with a high zero-tempco point. If this point is higher than the device's operating current, the device will tend to "run-away" thermally at the higher SOA power conditions^{1,2}. This thermal run-away condition is due to what has previously been labeled thermal focusing³. Therefore, the solution to improving SOA performance is operating the MOSFET above the zero-tempco point. While many manufacturers still show theoretical SOA, some are now quantifying their results with empirical data and displaying the limitations that this operating condition produces.

EPC's Gallium Nitride Solution to Improved SOA Performance:

Figure 1 represents the transfer characteristics of the EPC2001 eGaN FET, a 100 V, 7 milliohm device, compared with the BSB056N10NN3⁴ power MOSFET from Infineon. What is immediately obvious is that the temperature coefficient of the eGaN FET is positive throughout its range of operation. This means that when the temperature of a localized region of the device increases, its current carrying capability is reduced causing the current to be dispersed to other areas of the die. This dispersion of the current equalizes the temperature of the die, and is known as "self-ballasting." The power MOSFET, on the other hand, has a significant region of negative temperature coefficient operation (below 5.0 V on the gate) where there is no self-ballasting. Operation within this region creates localized hot spots within the die and, thus, limits the SOA capability of the die.

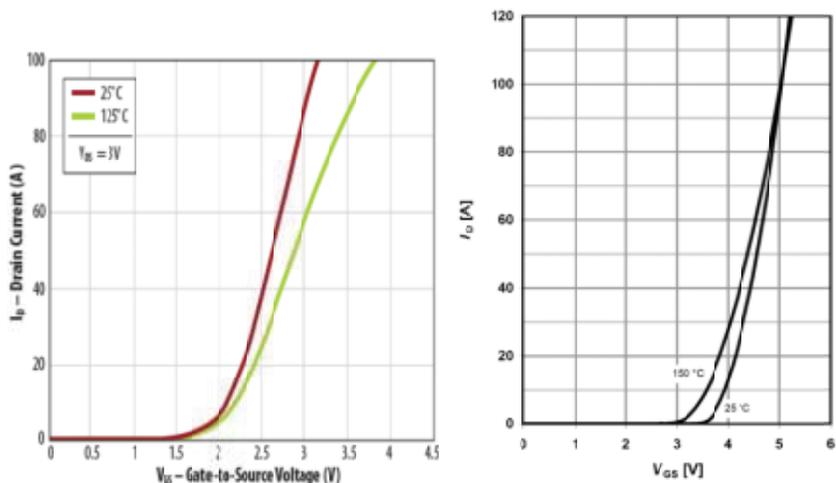
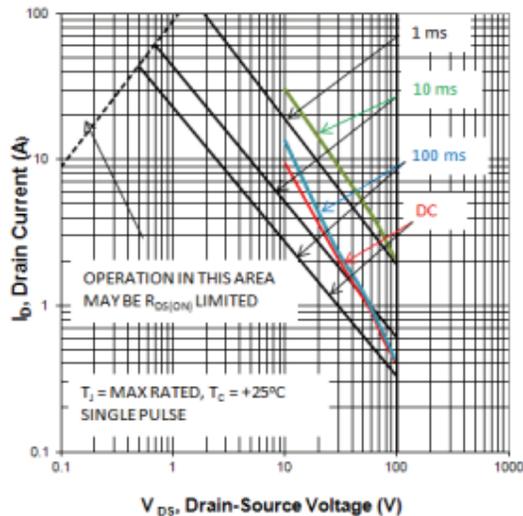


Figure 1: EPC2001 (left) and BSB056N10NN3 (right) transfer characteristics

Figure 2 shows the safe operating area of the EPC2001 eGaN FET compared with the same MOSFET from Infineon (BSB056N10NN3). The EPC2001 eGaN FET boundaries of the SOA curve are 100 V (the absolute maximum drain to source voltage), and 100 A (the absolute maximum pulse current). Within these boundaries, the transistor can operate for a limited amount of time before its thermal limit is reached.



Referring to figure 2:

1. The RED line shows failure data when the device was linearly biased under DC conditions.
2. The BLUE line shows failure data when the device was linearly biased for 100 milliseconds.
3. The GREEN line shows failure data when the device was linearly biased for 10 milliseconds.

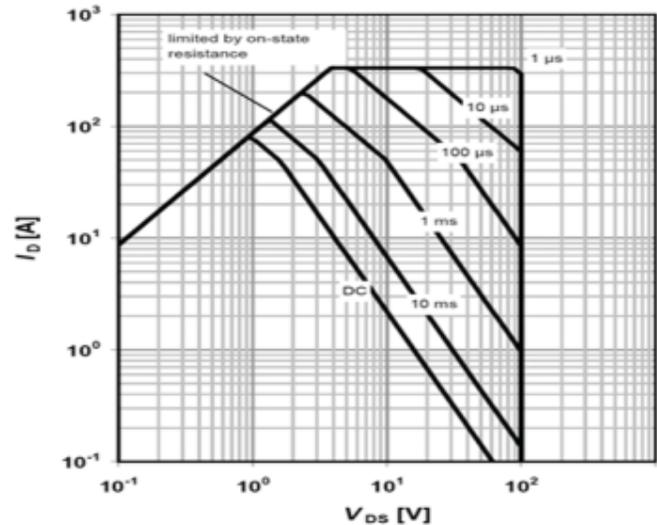


Figure 2: EPC2001 (left) and BSB056N10NN3 (right) Safe Operating Area

The top left portion of the graph cannot be reached because the $R_{DS(ON)}$ is too low to generate the voltage at the given current. Between the two boundary conditions exists a set of sloping lines that show SOA limitations as a function of a timed rectangular power pulse. The black lines are calculated constant power lines representing the energy it takes to raise the device junction temperature to the maximum rated junction temperature while maintaining a constant 25°C case temperature. These black lines typically have a slope of minus 1 (constant power: $\log(I_{DS}) = \log(P_D) - \log(V_{DS})$) at $V_{DS} = (I_{DS(continuous)})(R_{DS(ON)})$.

While the positive temperature coefficient over the entire operating range of the EPC2001 eGaN FET leads us to believe that the theoretical thermal limits bound safe operation, due diligence for a young technology drives us to verify this condition empirically to ensure that other failure modes are not overlooked. Twenty-five units of EPC2001 were taken to catastrophic failure where each device was clamped to a water-cooled heat sink; the case temperature was maintained at +25°C, $\pm 2.5^\circ\text{C}$.

As shown, the 10 millisecond, 100 millisecond and DC failures all occur at higher power levels than the published SOA conditions.

Conclusion

High electron densities and very low temperature coefficients give the eGaN FET major advantages over the power MOSFET needed for today's high performance applications. High electron density yields superior $R_{DS(ON)}$, while positive temperature coefficients inhibit hot spot generation within the die, resulting in superior Safe Operating Area capabilities. An additional benefit for eGaN FETs emerges when parallel devices are mounted onto a common heat sink. Due to their areas of positive temperature coefficient above the zero-tempco, they tend to current share, thus reducing the requirement for ballasting resistors.

References:

- [1] Worman, J., "New Generation Power MOSFETs and Safe Operating Area" PCIM proceedings, Chicago, 2002.
- [2] Schoiswohi, J., "Linear Mode Operation and Safe Operating Area of Power-MOSFETs," Applications Note, AP99007, Infineon, V0.92, 2010.
- [3] Ronan, H. R., Jr., "Thermal Current Focusing in Power MOSFETs" PCIM, Aug. 1998.
- [4] http://www.infineon.com/dgdl/BSB056N10NN3+G_Rev+2.5.pdf?folderId=db3a304313b8b5a60113cee8763b02d7&fileId=db3a30442e152e91012e390b9a631459